

F-7337


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shigeki SAKAI, et al.  
Serial No. : 10/090,851  
Filed : March 4, 2002  
For : SEMICONDUCTOR NONVOLATILE STORAGE  
ELEMENT AND METHOD OF FABRICATING  
THE SAME  
Group Art Unit : (Not yet known)  
Examiner : (Not yet known)

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on April 10, 2002.

Frank J. Jordan  
(Name)

  
(Signature)

04/10/02

Assistant Commissioner for Patents  
Washington, D.C. 20231

LETTER FORWARDING EXECUTED DECLARATION

Sir:

Attached hereto is a Declaration executed by the inventor. Please charge  
the cost of \$130.00 for filing this Declaration to Deposit Account Number 10-1250.

12/27/2002 UEDUVIJE 00000018 101250 10090851

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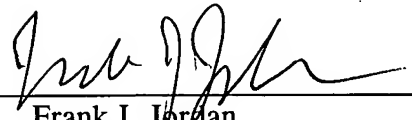
Ser. No. 10/090,851

If there are any additional charges, please charge to this same Deposit Account number.

Respectfully submitted,

Jordan and Hamburg LLP

By



Frank J. Jordan

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FJJ/pb